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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/627,648	07/28/2003	Koji Usuda	04329.3101	3609	
7590 11/16/2004		EXAMINER			
Finnegan, Henderson, Farabow,			CAO, PHAT X		
Garrett & Dunn	er, L.L.P.				
1300 I Street, N.W.			ART UNIT	PAPER NUMBER	
Washington, DC 20005-3315			2814		
			DATE MAILED: 11/16/2004	4	

Please find below and/or attached an Office communication concerning this application or proceeding.

on
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	Action Summary	Part of Paper No./Mail Date 1104		
Attachment(s)  1) ☑ Notice of References Cited (PTO-892)  2) ☑ Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) ☑ Information Disclosure Statement(s) (PTO-1449 or PTO/SB/06 Paper No(s)/Mail Date 7/03&8/04.		nary (PTO-413) ail Date nal Patent Application (PTO-152)		
Attachment(s)				
* See the attached detailed Office action for a lis	st of the certified copies not rec	eivea.		
application from the International Bure		a is call		
3. Copies of the certified copies of the priority documents have been received in this National Stage				
2. Certified copies of the priority documents have been received in Application No				
1.⊠ Certified copies of the priority docume	nts have been received.			
a)⊠ All b)□ Some * c)□ None of:	p.1011.j ulidol 00 0.0.0. g 11	~(~) ( <b>u</b> ) or (r).	`	
12)⊠ Acknowledgment is made of a claim for foreig	in priority under 35 U.S.C. & 11	9(a)-(d) or (f)		
Priority under 35 U.S.C. § 119		•		
11) The oath or declaration is objected to by the I	Examiner. Note the attached Of	fice Action or form PTO-152.		
Replacement drawing sheet(s) including the corre	- · ·			
Applicant may not request that any objection to the		•		
9) The specification is objected to by the Examir 10) The drawing(s) filed on is/are: a) a		he Examiner		
_	nor			
Application Papers	•			
8) Claim(s) are subject to restriction and	or election requirement.			
7)				
5)  Claim(s) is/are allowed. 6)  Claim(s) <u>1-12</u> is/are rejected.				
4a) Of the above claim(s) is/are withdr	awn from consideration.			
4) Claim(s) <u>1-12</u> is/are pending in the application				
Disposition of Claims				
	Ex parte Quayre, 1955 C.D. 1	, 700 0.0. 210.		
3) Since this application is in condition for allow closed in accordance with the practice under	·	•		
· <u> </u>	is action is non-final.			
1) Responsive to communication(s) filed on <u>09</u>				
Status				
earned patent term adjustment. See 37 CFR 1.704(b).				
THE MAILING DATE OF THIS COMMUNICATION  - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a re  - If NO period for reply is specified above, the maximum statutory perio  - Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mail	.136(a). In no event, however, may a reply ply within the statutory minimum of thirty (30 will apply and will expire SIX (6) MONTHS the cause the application to become ABAND	) days will be considered timely. from the mailing date of this communication. ONED (35 U.S.C. & 133).		
A SHORTENED STATUTORY PERIOD FOR REP		TH(S) FROM		
Period for Reply	opears on the cover sheet with t	ne correspondence address		
The MAILING DATE of this communication a	Phat X. Cao	2814		
Office Action Summary	Examiner	Art Unit		
	10/627,648	USUDA ET AL.		
	Application No.	Applicant(s)		

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## **DETAILED ACTION**

1. The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed.

2. The cancellation of claims 13-19 in paper filed 8/9/04 is acknowledged.

## Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 1, 4-7 and 10-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Imai et al (US. 5,847,419) in view of Nishikawa et al (Advanced LSI Technology Laboratory, Toshiba Corporation, pp. 174-175 cited by applicant).

Regarding claims 1, 4-5, 7, and 10-11, Imai (Fig. 3K) discloses a semiconductor apparatus comprising: a substrate 11; a buffer layer 15 made of monocrystal SiGe (column 10, lines 8-16) and formed on the substrate 11; a strained-silicon layer 16 (column 8, lines 42-45) formed on the buffer layer 15; a source region 22b and a drain region 22a formed in the strained-silicon layer 16 so as to be separated from each other; a gate insulating film 20 formed on the strained-silicon layer 16 sandwiched between the source/drain regions; and a gate electrode 21 formed on the gate insulating film 20. It is noted that because the silicon layer 16 is strained (column 8, lines 42-45), the underlay buffer layer 15 would have lattice constant which is different from that of the silicon layer 16.

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Imai does not disclose the gate insulating film 20 made of a monocrystal rare earth oxide having a lattice constant different from that of silicon 16.

However, Nishikawa teaches the forming of a gate insulating film on the silicon layer, and made of a monocrystal rare earth oxide of CeO2 having a lattice constant different from that of silicon (i.e., d=0.35%) (see Introduction on page 174). Accordingly, it would have been obvious to use the monocrystal rare earth oxide of CeO2 as an alternative dielectric for the gate oxide 20 of Imai because as taught by Nishikawa, such single crystalline CeO2 would provide an ultra-thin gate dielectric having high-K dielectric constant (see page 174).

Regarding claims 6 and 12, Imai's Fig. 3K further discloses that the buffer layer 15 is formed on the silicon substrate 11 through the insulating film 14.

5. Claims 2-3 and 8-9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Imai et al and Nishikawa as applied to claim (1, 7) above, and further in view of Hisamoto et al (US. 2003/0137017).

Neither Imai nor Nishikawa discloses the gate electrode made of crystalline SiGe.

However, Hisamoto (Fig. 1) teaches the forming of a gate electrode 11 made of crystalline SiGe (par. [0040]). Accordingly, it would have been obvious to use the crystalline SiGe as an alternative material for the gate electrode because as taught by Hisamoto, such crystalline SiGe gate electrode would provide a different work function depending on its composition ratio (par. [0041]).

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6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Phat X. Cao whose telephone number is (571) 272-1703. The examiner can normally be reached on Monday - Thursday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael Fahmy can be reached on (571) 272-1705. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

PC

November 12, 2004

PHAT X. CAO